

August 27, 2003

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject:

Divisional Patent Application of
Serial No.: 09/981,436 10/18/01

JURING-YI CHENG, KEVIN SU

A NOVEL CHEMICAL-MECHANICAL POLISHING
(CMP) PROCESS FOR SHALLOW TRENCH ISOLATION

PRELIMINARY AMENDMENT

Dear Sir:

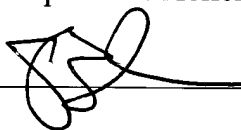
This is a preliminary amendment for the above referenced Divisional Patent Application. Please amend the above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on August 27, 2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature/Date

 8/27/03